



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of

Takayoshi Sawayama

Group Art Unit: 1763

Serial No.: 09/754,277

Examiner: Alejandro Mulero, Luz L #3

Filed: January 5, 2001

1/17/02  
Mw

For: PLASMA ETCHING APPARATUS

**RESPONSE TO ELECTION/RESTRICTION REQUIREMENT**

Honorable Commissioner of  
Patents and Trademarks,  
Washington, D.C. 20231

Sir:

In response to the Office Action of December 18, 2001, Applicant elects the invention of specie B, which corresponds to claims 3-7, directed to an apparatus comprising a pressure detecting means. The election is without traverse.

Respectfully submitted,

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